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Docket No. ENT TRANSMITTAL LETTER SON-1968 Application No. Filing Date Art Unit Examiner 09/739,739-Conf. #4967 December 20, 2000 Elizabeth M. Keaney 2882 Applicant(s): Masakazu MUROYAMA et al. CATHODE FOR AN ELECTRON EMISSION DEVICE, COLD CATHODE FIELD EMISSION DEVICE AND METHOD FOR THE PRODUCTION THEREOF, AND COLD CATHODE Invention: FIELD EMISSION DISPLAY AND METHOD FOR THE PRODUCTION THEREOF HAVING A CARBON FILM SELECTIVE-GROWTH REGION (As Amended) TO THE COMMISSIONER FOR PATENTS Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. **CLAIMS AS AMENDED** Claims Highest Remaining Number Number After Previously Extra Claims Amendment Paid Present Rate **Total Claims** 79 79 0.00 Independent 12 12 Х 0.00 Claims Multiple Dependent Claims (check if applicable) Other fee (please specify): TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: 0.00 x Large Entity Small Entity x No additional fee is required for this amendment. Please charge Deposit Account No. in the amount of \$ A duplicate copy of this sheet is enclosed. A check in the amount of \$ to cover the filing fee is enclosed. Payment by credit card. Form PTO-2038 is attached. x The Commissioner is hereby authorized to charge and credit Deposit Account No. 18-0013 as described below. A duplicate copy of this sheet is enclosed. Credit any overpayment. Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17. Dated: October 9, 2003 Ronald P. Kananen Attorney Reg. No.: 24,104 RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W., Suite 501 Washington, DC 20036 (202) 955-3750



Docket No.: SON-1968 (80001-1968)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Masakazu Muroyama, et al

Application No.: 09/739,739

Filed: December 20, 2000

Confirmation No.: 4967

Group Art Unit: 2882

Examiner: Elizabeth M. Keaney

For: CATHODE FOR AN ELECTRON EMISSION

DEVICE, COLD CATHODE FIELD EMISSION

DEVICE AND METHOD FOR THE PRODUCTION THEREOF, AND COLD

CATHODE FIELD EMISSION DISPLAY AND

METHOD FOR THE PRODUCTION THEREOF HAVING A CARBON FILM SELECTIVE-GROWTH REGION (As

Amended)

RESPONSE UNDER 37 CFR 1.116

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed August 6, 2003 (Paper No. 11), no claim amendments are presented. All pending claims with their identifiers are listed beginning at page 2.